Application No.: 10/606,348

Docket No.: 2336-183

ABSTRACT

Disclosed is an An MEMS variable optical attenuator comprising includes a substrate having a planar surface, a micro-electric actuator arranged on the planar surface of the substrate, a pair of coaxially aligned optical waveguides having a receiving end and a transmitting end, respectively, and coaxially aligned with the other while being arranged on the planar surface, an optical shutter movable to a predetermined position between the receiving end and the transmitting end of the optical waveguides, and driven to move by the micro-electric actuator, and a. A surface layer is formed on the optical shutter, having has reflectivity less than 80% so as [[for]]to allow incident light beams to partially transmit thereinto, and having a characteristic of further has a sufficient light extinction ratio, thereby extinguishing the partially transmitted light beams therein.